

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/615,926 Confirmation No. : 9914  
First Named Inventor : Hideaki YAMASAKI  
Filed : July 10, 2003  
TC/A.U. : 1792  
Examiner : Jeffrie. R. LUND  
  
Docket No. : 010986.52578US  
Customer No. : 23911  
  
Title : Film-Formation Apparatus and Source Supplying  
Apparatus Therefor, Gas Concentration Measuring Method

**REPLY**

**Mail Stop AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the Office Action dated September 19, 2008. **An extension of the deadline for response to the Office Action is respectfully requested pursuant to 37 C.F.R. § 1.136(a) and the appropriate fee is submitted herewith.**

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. ***No additional claims fees are due.***

**Remarks** begin on page 12 of this paper.